

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)			ATTY. DOCKET NO. 57810-088	SERIAL NO. 10/790759			
			APPLICANT Eiji MARUYAMA				
			FILING DATE March 03, 2003	GROUP 1709			
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code(s if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
	US						
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FOREIGN PATENT DOCUMENTS					Translation		
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Code-Number + Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Yes	No
JS		JP 5-136440	06/01/1993	SANYO ELECTRIC CO LTD.		JAPAN (w/English Abstract)	
OTHER ART (including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
JS		"Present Situation of ITO Deposition Technique for LCD and Mass Production Device." ULVAC Technical Journal No. 39, 1992, pp. 29-34.					
EXAMINER /Jackson Smith/			DATE CONSIDERED 03/12/2007				

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